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Bib Data Sheet

CONFIRMATION NO. 6213

SERIAL NUMBER 10/644,745	FILING OR 371(c) DATE 08/21/2003 RULE	CLASS 310 250	GROUP ART UNIT 2884 2878	ATTORNEY DOCKET NO. 07553.0044
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APPLICANTS

Hideki Tanaka, Yamanashi, JAPAN;

**** CONTINUING DATA ********None***** FOREIGN APPLICATIONS *******JAPAN 2002-241454 08/22/2002 *M***IF REQUIRED, FOREIGN FILING LICENSE GRANTED ****

11/18/2003

**** SMALL ENTITY ****

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 8	TOTAL CLAIMS 12	INDEPENDENT CLAIMS 9
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged <i>[Signature]</i> Examiner's Signature <i>[Initials]</i>				

ADDRESS

22852

TITLE

Plasma leak monitoring method, plasma processing apparatus and plasma processing method

FILING FEE RECEIVED 822	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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